Effect of Intermediate Metal on the Methanol Gas Sensitivity of ITO Thin Films

H. M. Lee, S. B. Heo, Y. M. Kong, and Daeil Kim*

School of Materials Science and Engineering, Ulsan University, Ulsan 680-749

(Received February 15, 2011, Revised April 13, 2011, Accepted April 13, 2011)

ITO thin films and gold (Au), copper (Cu) and nickel (Ni) intermediate ITO multilayer (ITO/Au/ITO, ITO/Cu/ITO, ITO/Ni/ITO) films were deposited on glass substrates with a reactive radio frequency and direct current magnetron sputtering system and then the effect of intermediate metal layer and annealing temperature on the methanol gas sensitivity of ITO films were investigated. Although both ITO and ITO/metal/ITO (IMI) film sensors have the same total thickness of 100 nm, IMI sensors have a sandwich structure of ITO 50 nm/metal 10 nm/ITO 40 nm. The change in the gas sensitivity of the film sensors caused by methanol gas ranging from 100 to 1000 ppm was measured at room temperature. The IAI film sensors showed the higher sensitivity than the other sensors. Finally, it is concluded that the ITO 50/Au 10/ITO 40 nm film sensors hasthe potential to be used as improved methanol gas sensor.

Keywords : ITO, Multilayer, Magnetron sputtering, Gas sensor

I. Introduction

Currently, thin film gas sensors for hazardous gases have attracted much attention due to growing environmental safety concerns. A number of semi-conductive oxides such as SnO₂ have been used for different gas sensors [1].

Most of these gas sensors are based on a variation in resistance when the film sensors are exposed to target gases. Since most methanol gas sensors operate at relatively high temperatures, a heater is required [2]. However, integration of a heater in gas sensors not only increases the power consumption but also the complexity of the device. Thus, it is very desirable to decrease the operating temperature for viable gas sensors in industrial applications.

In this study, Sn doped In₂O₃ (ITO) thin films and 10 nm thick Au, Cu and Ni intermediate ITO films (IAI, ICI, INI) were prepared, respectively and then the effects of the intermediate metal layer on the electrical and structural properties of the films and post-deposition annealing on the methanol gas sensitivity of the films were investigated with Cu–K X-ray diffraction (XRD), atomic force microscopy (AFM), four–point probes and gas sensing measurements, respectively.

II. Experiments

Deposition of ITO and Au, Cu, and Ni thin films was performed in a magnetron sputtering system that was equipped with two cathodes, radio frequency (RF)
(3.2 W/cm², 13.56 MHz) and direct current (DC) (3.0 W/cm²) powers were applied to ITO (In₂O₃ 90%∼SnO₂ 10%, purity; 99.99%) and metal (Au, Cu, and Ni) targets (purity; 99.99%), respectively. ITO and intermediate metal (Au, Cu, Ni) films were deposited onto glass (Corning 1747) substrates with constant deposition rate of 14 and 10 nm/minute, respectively at an optimized gas flow condition. Substrate temperature was detected by a K-type thermocouple.

Although the substrate was not heated intentionally, substrate temperature increased up to 70°C during deposition. The distance between the target and substrate was constant at 10 cm. Substrate rotation speed was set to 10 rpm for all depositions. By controlling deposition time, the thickness of ITO and IMI films were kept constant at 100 nm and 50/10/40 nm, respectively.

The film’s thickness was confirmed with a surface profilometer, and Cu–K XRD (X’pert Pro MRD, Philips) analysis at the Korea Basic Science Institute (Daegu center) was used to observe the crystalline. The electrical properties of the films were measured via a Hall Effect measurement system (HMS–3000, Ecopia), while surface morphology and root mean square (RMS) roughness of the films were obtained via an AFM (XE-100, Park system).

In this study, all gas sensing measurements were carried out at room temperature and the gas concentration was varied from 100 to 1,000 ppm. Ag electrodes (0.5 cm²) for measuring sensitivity to methanol vapor were deposited onto the prepared sensors by thermal evaporation. A thin gold wire was attached to the Ag electrode with Ag paste to analyze the conductivity. The film sensors which have the higher gas sensitivity (S) was annealed at 200°C and 400°C for 30 min to consider the effect of annealing in a vacuum of 1×10⁻³ Torr on the methanol sensitivity. The schematic diagram of the static measurement set-up used to measure the gas sensitivity was reported in a previous report [3].

### III. Results and Discussion

It is well known that ITO films deposited by magnetron sputtering at low temperature are usually amorphous [4, 5]. Fig. 1 shows the XRD pattern of the as-deposited IMI multilayer films. Although INI and ICI films revealed an amorphous phase, IAI films show the Au (111) and In₂O₃ (431) diffraction peaks on the XRD pattern by an inherent nucleation seed effect of Au. The crystallization of ITO by an Au under layer was described in a previous report [6].

Fig. 2 shows the SEM images of the ITO and IAI films. ITO films do not have any grains on the surface, while IAI films show some grains on the surface.

Fig. 3 shows the surface morphology (scan area
Effect of Intermediate Metal on the Methanol Gas Sensitivity of ITO Thin Films

Figure 3. AFM images of ITO and IAI films. (a) ITO (RMS roughness 0.6), (b) ITO/Au/ITO (RMS roughness 1.1).

Table 1. Comparison of the carrier density ($10^{19}$/cm$^3$), mobility (cm$^2$/Vs) and electrical resistivity ($10^{-4}$ Ωcm), of ITO and IMI films.

<table>
<thead>
<tr>
<th></th>
<th>Carrier density</th>
<th>Mobility</th>
<th>Resistivity</th>
</tr>
</thead>
<tbody>
<tr>
<td>ITO</td>
<td>2.1</td>
<td>133</td>
<td>22.2</td>
</tr>
<tr>
<td>INI</td>
<td>3.0</td>
<td>65</td>
<td>3.3</td>
</tr>
<tr>
<td>ICI</td>
<td>5.4</td>
<td>39</td>
<td>1.5</td>
</tr>
<tr>
<td>IAI</td>
<td>22.1</td>
<td>47</td>
<td>0.5</td>
</tr>
</tbody>
</table>

$2\times2$ μm$^2$ of ITO (a) and IAI (b) films, INI and ICI films show a RMS roughness of 0.6, and 0.8 nm, respectively. As shown in Fig. 3, IAI films show a higher RMS roughness (1.1 nm) than that of the other films.

Table 1 shows the carrier density, mobility, and electrical resistivity of the ITO and IMI films evaluated with Hall Effect measurements. In general, oxygen gas flow rate during transparent and conducting oxide (TCO) deposition is very effective in improving carrier concentration because each oxygen vacancy on the In$_2$O$_3$ matrix donates two electrons. Although a severe oxygen deficiency also causes high resistivity due to structural disorder and reduced mobility in oxygen vacancies, moderate deficiency of oxygen in In$_2$O$_3$ film is favorable to the electrical conductivity due to optimized carrier density [7].

However, in this study all of the ITO films were deposited under a constant oxygen flow rate of 0.5 sccm. Thus, the observed change in carrier density does not originate from oxygen vacancies, rather the increased carrier density stems from the intermediate Au, Cu, and Ni films. In Table 1, although ITO single layer films show the highest mobility, the IAI films show the lowest resistivity of $5\times10^{-5}$ cm due to extremely high carrier density of $22.1\times10^{19}$/cm$^3$. Fig. 4 shows the variation in the sensitivity(S) at room temperature as a function of methanol vapor concentration for ITO and IMI film gas sensor.
ing equation:

\[ S = \frac{R_{\text{air}}}{R_{\text{gas}}} \]

Where \( R_{\text{gas}} \) is the resistance of the film sensor in presence of methanol vapors and \( R_{\text{air}} \) the resistance in air, which should be constant for a given test temperature [8].

Recently, V. S. Vaishnav studied the influence of a stimulating layer of MgO below the ITO film on the ethanol sensitivity [3]. The stimulating layer of MgO shows enhancement in the sensitivity related to a change in resistance with an improvement of 23 times that of the single ITO layer films. In Fig. 4, the gas sensitivity of all sensors increased with gas concentration and the 10 nm thick Au intermediate IAI film sensors show a higher sensitivity than that of the other sensors within the observed methanol vapor concentration. From AFM images, it is supposed that the increased surface area by rough surface of the IAI film may enhances the sensitivity.

Table 2 shows the variation in the sensitivity of the IAI films as a function of annealing temperature. In a previous study, the increased ITO and Au diffraction peak in a XRD pattern by annealing process were reported [9] already. Thus the increased sensitivity of IAI films in Table 2 is attributed to the large grain size by annealing that results in the lower electrical resistivity than that of as deposited IAI films. The result is similar with ZnO film sensor for hydrogen detection under various operation temperatures [10].

### IV. Conclusions

The changes in sensitivity for methanol gas of ITO/metal (Au, Cu, and Ni)/ITO (IMI) film were investigated at room temperature and then compared to those of conventional ITO film sensors. It was demonstrated that the IMI film sensor shows increased sensitivity to methanol gases compared to ITO film sensors. Further, 10 nm thick Au intermediate IAI films show higher sensitivity than other films.

Finally, it can be concluded that the ITO 50nm/Au 10 nm/ITO 40 nm film sensors have the potential to be used as improved methanol gas sensors.

### References

층간금속층에 따른 ITO 박막의 메탄올 검출민감도 개선 효과

이학민 · 허성보 · 공영민 · 김대일 *
울산대학교 첨단소재공학부, 울산 680-749

RF 마그네크론 스퍼터와 DC 마그네클론 스퍼터를 병행하여 ITO/Au/ITO, ITO/Cu/ITO, 그리고 ITO/Ni/ITO 박막을 유리판 위에 증착하였다. 증착 후 진공열처리를 통하여 층간 금속층이 ITO박막의 메탄올 검출 민감도에 미치는 영향을 분석하였다. 모든 박막센서의 두께는 100 nm으로 동일하게 ITO 50 nm/metal 10 nm/ITO 40 nm로 제작되었고 메탄올 농도는 100에서 1,000 ppm까지 달리하였다. ITO/Au/ITO 박막сен서가 가장 높은 민감도를 보임으로써 ITO/Au/ITO 다층박막이 기존의 ITO 메탄올 센서를 대체할 수 있는 센서임을 확인하였다.

주제어 : ITO, 다층, 마그네크론 스퍼터, 가스센서

* [전자우편] dkim84@ulsan.ac.kr